

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Doerr et al.

Application No. 10/801,481

Filed: March 15, 2004

FILED VIA EFS ON NOVEMBER 24, 2008

Confirmation No. 1207

For: LINEAR OPTICAL SAMPLING
METHODS AND APPARATUS

Examiner: Wai Lun Leung

Art Unit: 2613

Attorney Reference No. 1505-67922-01

COMMISSIONER FOR PATENTS

SUPPLEMENTAL RESPONSE TO RESTRICTION REQUIREMENT

This response supplements the Response to Restriction Requirement filed by Applicants on November 10, 2008. Please amend the referenced application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2.

Remarks begin on page 7.